EMVA
18th Business Conference
June 25th – 27th, 2020
Sofia – Bulgaria

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EMVA 2020 Young Professional Award

- Call for Papers -

The **EMVA Young Professional Award** is an annual award endowed with 1500 Euros to honor the outstanding and innovative work of a student or a young professional in the field of machine vision or image processing.

It is the goal of the European Machine Vision Association EMVA to support further innovation in our industry, to contribute to the important aspect of dedicated machine vision education and to provide a bridge between research and industry.

The winner of the award will be announced at the 18th EMVA Business Conference 2020 taking place June 25th – 27th in Sofia, Bulgaria, and will have the opportunity to present the awarded work to the machine vision industry leaders from Europe and abroad. This presentation will then be published by the international machine vision press.

Connected to the honor of the **EMVA Young Professional Award** endowed with 1500 Euros and the publicity for the research work is a free conference pass for the EMVA Business Conference as well as the coverage of all travel cost to Sofia and a free pass for the 2020 *European Machine Vision Forum* in Ireland.

With our award, we would like to specifically encourage students and young scientists to focus on challenges in the field of machine vision and to apply latest research results and findings in computer vision to the practical needs of our industry.

The criteria of the works to be presented for the EMVA Award are:

(1)   Outstanding innovative work in the field of vision technology.
          Industrial relevance and collaboration with a company during the work is required.
          The targeted industry is free of choice.

(2)   Work (master thesis or PHD thesis) has to be made within the last 12 months at (or in collaboration with) a European institution. Meanwhile the student may have entered the professional field.

A short abstract of 1-2 pages in English language has to be submitted to the EMVA Secretariat, Ms. Nadine Kubitschek, at ypa@emva.org latest until May 11th, 2020.

Among the papers the EMVA Board of Directors, representing the European Machine Vision Industry, will select the winner of the award.

The EMVA Board of Directors